

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|-------|---|---|------------------|---------|------------------|
| L1 | 63945 | (electrode anode cathode) same pad and contact and (wafer semiconductor microelectronics micropiece) and abrasive and (proximate proximity) without near3 (touching contacting) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:13 |
| L2 | 6 | 1 and 205/147 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:09 |
| L3 | 6 | 1 and 205/147.ccls. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:11 |
| L4 | 41 | 1 and 204/242 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:12 |
| L5 | 48271 | (electrode anode cathode) same pad and contact and (wafer semiconductor microelectronics micropiece) and abrasive and (proximate proximity) without near (touching contacting) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:14 |
| L6 | 26 | 5 and (204/242.ccls. or 205/147.ccls.) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:15 |
| L7 | 1 | ("6398625").PN. | USPAT; USOCR | OR | OFF | 2007/07/03 07:18 |
| L8 | 1 | ("6168693").PN. | USPAT; USOCR | OR | OFF | 2007/07/03 07:19 |
| L9 | 1 | ("6103096").PN. | USPAT; USOCR | OR | OFF | 2007/07/03 07:19 |
| L10 | 1 | ("6797132").PN. | USPAT; USOCR | OR | OFF | 2007/07/03 07:22 |
| L11 | 98 | (205/147).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:22 |

EAST Search History

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|-----|------|-----------------|---|----|-----|------------------|
| L12 | 1394 | (204/242).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT | OR | OFF | 2007/07/03 07:22 |
|-----|------|-----------------|---|----|-----|------------------|